

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
SHIGERU SUGIOKA	04/27/2018
KIYONORI OYU	04/25/2018
HIROSHI TOYAMA	04/24/2018
JUNG CHUL PARK	05/08/2018
RAJ K. BANSAL	05/15/2018
RECEIVING PARTY DATA	
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Street Address:	8000 SOUTH FEDERAL WAY, MS 1- 525
City:	BOISE
State/Country:	IDAHO
Postal Code:	83716
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	15981619
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NAME OF SUBMITTER:	BRIDGET WISEMAN
SIGNATURE:	/Bridget Wiseman/
DATE SIGNED:	05/16/2018
Total Attachments: 8	

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ASSIGNMENT

PARTIES TO THE ASSIGNMENT:

INVENTORS:

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8th Floor, Shinagawa Season Terrace
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Raj K. BANSAL
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Xitun Dist. Taichung City, Taiwan 407.

ASSIGNEE:

Micron Technology, Inc.
MS 1-525
8000 South Federal Way
Boise, ID 83716
United States

BACKGROUND OF THIS ASSIGNMENT:

Inventors have conceived certain new and useful inventions disclosed in a United States patent application titled "Substrates, Structures Within A Scribe-Line Area Of A Substrate, And Methods Of Forming A Conductive

Line Of A Redistribution Layer Of A Substrate And Of Forming A Structure Within A Scribe-Line Area Of The Substrate".

Micron Technology, Inc. (hereinafter referred to as "ASSIGNEE") desires to acquire the entire right, title and interest in said inventions and with respect to any Letters Patent that may be granted with respect to the inventions in both the United States and in all foreign countries.

THE PARTIES AGREE AS FOLLOWS:

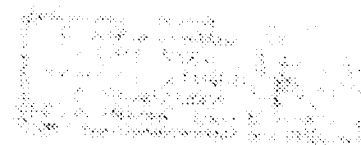
In consideration of good and valuable consideration, the receipt, sufficiency and adequacy of which is hereby acknowledged, INVENTORS have sold, assigned and transferred, and by these presents does hereby sell, assign and transfer to ASSIGNEE the entire right, title and interest in the above-identified inventions and application and to any reissues, renewals, divisions or continuations of the application thereof, and hereby authorizes the Commissioner of Patents and Trademarks to issue such Letters Patent to ASSIGNEE for the sole use of ASSIGNEE, its successors or assigns.

INVENTORS further agree to execute, at the request and expense of ASSIGNEE, such other formal documents as may be required to fully convey the interest transferred herein and will similarly execute any patent application papers (domestic or foreign) required for the filing of any divisional, continuation, renewal or reissue of the patent application or resulting Letters Patent; and will generally do everything necessary or desirable to obtain and enforce proper protection for the inventions assigned hereby.

INVENTORS further assign to ASSIGNEE the whole right, title and interest in the inventions disclosed in the application throughout all countries foreign to the United States. ASSIGNEE is hereby authorized to apply for patents relating to the inventions in its own name in countries where such procedure is proper; to claim the benefit of the International Convention; to file and prosecute International Applications relating to the

inventions under the Patent Cooperation Treaty; and to file and prosecute applications relating to the inventions under the European Patent Convention. INVENTORS agree to execute applications relating to the inventions in those countries and under those conventions where it is necessary that the same be executed by the inventor, and to execute assignments of such applications and the resulting Letters Patent to ASSIGNEE as well as all other necessary papers in relation to such applications and Letters Patent. INVENTORS hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any document which may be required in any country as proof of the right of ASSIGNEE to apply for patent and other form of protection for said inventions and to claim the aforesaid benefit of the right of priority.

To be binding on the heirs, assigns, representatives and successors of the undersigned and extend to the successors, assigns and nominees of the Assignee.



Dated: 2018/04/27

Signature: 
Shigeru SUGIOKA

WITNESS:

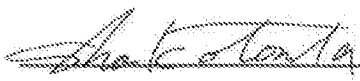
Dated: 2018/4/27

Signature: 
Printed Name: Yasuhiro Yamaya
Address: c/o Micron Memory Japan

8th Floor, Shinagawa Season Terrace
1-2-70, Konan, Minato-ku, Tokyo, Japan 108-0075

WITNESS:

Dated: 04/27/2018

Signature: 
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Dated: April 25, 2018

Signature: Kiyonori Oyu
Kiyonori OYU

WITNESS:

Dated: 2018/4/25

Signature: [Signature]
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WITNESS:

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Dated: 04/24/2018

Signature: Hiroshi Toyama
Hiroshi TOYAMA

WITNESS:

Dated: 2018/4/24

Signature: Yasuhiro Yamaya
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WITNESS:

Dated: 04/24/2018

Signature: Shoko Tomita
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Address: c/o Micron Memory Japan

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Dated: 5/8/2018

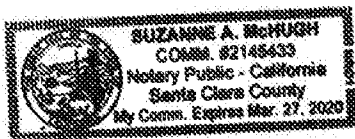
Signature: Jung Chul PARK
Jung Chul PARK

State of California)
County of Santa Clara) ss.

On this 8 day of MAY, 2018, before me, Suzanne A. McHugh (name and title of Notary Official), personally appeared Jung Chul PARK, known or identified to me (or proved to me on the basis of satisfactory evidence) to be the person whose name is subscribed within the Assignment, and acknowledged to me that he/she executed the Assignment in his/her authorized capacity, and that by his/her signature on the Assignment, the person executed the Assignment.

SEAL

Suzanne A. McHugh
My Commission Expires: March 27, 2020



Dated: 05/15/2018

Signature: *R. K. Bansal*
Raj K. BANSAL

WITNESS:

Dated: 05/15/2018

Signature: *Yang Kuo Rong*
Printed Name: KR Yang
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Houli Dist, Taichung City, Taiwan

WITNESS:

Dated: 05/15/2018

Signature: *Bang-Ning Hsu*
Printed Name: Bang-Ning Hsu
Address: No. 13 Alley 4th Lane 111 Da-Lin Rd.
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Taiwan